

PTO-1449 Information Disclosure Citation in an Application			Application No.	Applicant(s)			
			10/735,477	David C. Hovda			
			Docket Number	Group Art Unit	Filing Date		
			S-16	3739	December 11, 2003		
U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
/MP/	A.	5,098,431	03/24/92	Rydell	606	48	07/03/90
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	C.	5,417,687	05/23/95	Nardella et al.	606	32	04/30/93
	A.	6,261,286	07/17/01	Goble et al.	606	34	10/16/98
	B.	6,261,311	07/17/01	Sharkey et al.	607	96	7/30/99
	C.	6,264,652	07/24/01	Eggers et al.	606	41	05/18/99
	D.	6,277,112	08/21/01	Underwood et al.	606	32	02/20/98
	E.	6,280,441	08/28/01	Ryan	606	45	12/15/97
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	G.	4,573,448	3/4/86	Kambin	606	170	10/5/1983
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	I.	5,571,189	11/5/96	Kuslich	623	17.12	5/20/1994
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✓	M.	6,761,718	7/13/04	Madsen	606	50	9/6/2001
/MP/	N.	7,108,696	9/19/06	Daniel et al.	606	41	9/22/2003
EXAMINER /Michael Peffley/				DATE CONSIDERED 11/01/2007			
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/MP/	D.	2005/0234439	10/20/05	Underwood et al.	606	032	03/25/05
/MP/	E.	2005/0251134	11/10/05	Woloszko et al.	606	032	05/09/05
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FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
/MP/	A.	05/000434	12/20/06	NL	--	--	X
/MP/	B.	05/125287	12/29/05	WO	A61B	18/00	X

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/MP/	A. AESCULAP, "Flexible endoscope", Micro, Neuro and Spine surgery, 9 pgs	No Date
/MP/	B. Stoffels, E. et al., "Investigation on the Interaction Plasma-Bone Tissue", E-MRS Spring Meeting, 1 pg	06/18-21/2002
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/MP/	H. Stoffels, E. et al., "Plasma Treated Tissue Engineered Skin to Study Skin Damage", Biomechanics and Tissue Engineering, Materials Technology, 1 pg	2003

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		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)		DATE
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/MP/ B.		Stoffels, E. et al., "The Effects of UV Irradiation and Gas Plasma Treatment on Living Mammalian Cells and Bacteria: A Comparative Approach", IEEE Transaction on Plasma Science, Vol. 32, No. 4, pp. 1544-1550		08/2004
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